SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449

Docket No.	Application No.				
52433/820	10/551,159				
Applicant(s)	Examiner				
TANAKA et al.	Michael E. LAVILLA				
Filing Date	Confirmation No.	Art Unit			
September 28, 2005	3164	1775			

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE
/ML/	2001/0031377	October 18, 2001	Hashimoto et al.	1		
/ML/	2002/0160221	October 31, 2002	Takeda et al.			
/ML/	2003/0054195	March 20, 2003	Ishii et al.			
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						TRANSLATION	
EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	Yes	No
/ML/	EP 1 076 105 A1	February 14, 2001	EP				
/ML/	EP 1 149 928 A1	October 31, 2001	EP				
/ML/	JP 2001-279412	October 10, 2001	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.			
/ML/	Supplementary European Search Report of European Patent Application No. EP 04 72 4397 mailed November 22, 2007			

EXAMINER /Michael LaVilla/

DATE CONSIDERED

06/01/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.